WORLD INTELLECTUAL PROPERTY ORGANIZATION



INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification 6; H01L 23/02, 21/44, B29C 13/00

(11) International Publication Numbers (43) International Publication Date:

WO.99/56316

(31) International Application Number:

PCT/US99/09020

(22) International Piling Date:

26 April 1999 (26.04.99)

(30) Priority Data:

09/067,698

28 April 1998 (28.04.98)

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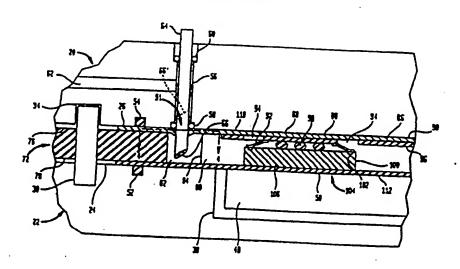
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4 November 1999 (04.11.99) (81) Designated States: AE, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, CA, CH, CN, CU, CZ, DE, DK, EE, ES, FI, GB, GD, OE, GR, GM, HR, HU, ID, IL, IN, IS, IP, KE, KO, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MD, MG, MC, MN, MW, MOX, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TR, TT, UA, UG, UZ, VN, YU, ZA, ZW, ARIPO patent (GH, GM, KE, LS, MW, SD, SL, SZ, UG, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), Buropean patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, FT, SE), OAPI patent (BF, BJ, CF, CO, CI, CM, GA, GN, GW, ML, MR, NE, SN, TD, TO).

Published

With international search report.

(54) Title: ENCAPSULATION OF MICROELECTRONIC ASSEMBLIES



Microelectronic assemblies are encapsulated using disposable frames (72). The microelectronic assemblies (104) are disposed within an aperture (80) defined by a frame. The aperture is covered by top and bottom scaling layers (110, 112) so that the frame and scaling layers from the encapsulation fixture and held in a curing oven. After cure, the frame is out over and the individual assemblies are anyoned from from the encapsulation fixture and held in a curing oven. After cure, the frame is cut apart and the individual assemblies are severed from another. Because the frame need not be held in the encapsulation fixture during curing, the process achieves a high throughput.